

Amendments to the Claims:

This listing of claims will replace all prior versions, and listings of claims in the application:

Listing of Claims:

1 (1-62) (Canceled)

1 63. (New) A method of forming a thermally insulating layer system on a
2 metallic substrate surface, comprising:

3 forming a plasma beam;

4 introducing a coating material in the form of a powder having particles in the
5 range between 1 and 50 µm, carried by a delivery gas into the plasma beam, so as to form a
6 powder beam;

7 defocusing the powder beam by using the plasma beam with a sufficiently high
8 specific enthalpy and by maintaining a process pressure between 50 and 2000 Pa for at least
9 partially melting some of the powder and vaporizing at least 5% by weight of the powder, so as
10 to form a vapor phase cloud; and

11 forming from the vapor phase cloud onto the metallic substrate surface an
12 insulating layer, being a part of said insulating layer system, having an anisotropic columnar
13 microstructure having elongate particles;

wherein said anisotropic columnar microstructure is aligned substantially perpendicular to the metallic substrate surface and low-density transition regions with little material delimit the elongate particles relative to one another.

1 64. (New) The method of claim 63, wherein said forming a thermally
2 insulating layer system on a metallic substrate surface comprises using a low pressure plasma
3 spray (LPPS) system.

1 65. (New) The method of claim 63, wherein said plasma beam with a
2 sufficiently high specific enthalpy comprises a plasma beam having an effective power in the
3 range between 40 and 80 kW.

1 66. (New) The method of claim 63, comprising maintaining a process
2 pressure between 100 and 800 Pa.

1 67. (New) The method of claim 63, wherein the process gas for the
2 generation of the plasma beam comprises a mixture of inert gases with a total flow in the range
3 between 30 and 150 SPLM.

1 68. (New) The method of claim 67, wherein the mixture of inert gases
2 comprises argon and helium, with the volume ratio of argon to helium preferably amounting to 2
3 : 1 to 1 : 4.

1 69. (New) The method of claim 63, wherein the powder supply rate of the
2 coating material is between 5 and 60 g/min.

1 70. (New) The method of claim 63, wherein the powder supply rate of the
2 coating material is between 10 and 40 g/min.

1 71. (New) The method of claim 63, wherein the thermally insulating layer is
2 used in a gas turbine and its layer thickness is the range between 20 and 1000 µm.

1 72. (New) The method of claim 63, wherein the thermally insulating layer is
2 used in a gas turbine and its layer thickness is at least 100 µm.

1 73. (New) The method of claim 63, comprising moving the substrate during
2 said forming an insulating layer, with a rotary movement relative to the vapor phase cloud.

1 74. (New) The method of claim 63, comprising moving the substrate during
2 said forming an insulating layer, with a pivoting movement relative to the vapor phase cloud.

1 75. (New) The method of claim 63, wherein said coating material comprises
2 oxide ceramic components, wherein an oxide ceramic component of the coating material is a
3 zirconium oxide completely or partly stabilized with yttrium, cerium or other rare earths and
4 wherein the material used as a stabilizer is alloyed with the zirconium oxide in the form of an
5 oxide of said rare earths.

1 76. (New) The method of claim 75, wherein the size distribution of the
2 powder particles of the coating material is determined by means of a laser scattering method,
3 with spray drying or a combination of melting and subsequent breaking and/or grinding being
4 used as a method for the manufacture of the power particles.

1 77. (New) The method of claim 75, wherein the size distribution of the
2 powder particles of the coating material is determined by means of a laser scattering method and
3 wherein this size distribution lies substantially in the range between 3 and 25 µm, with spray
4 drying or a combination of melting and subsequent breaking and/or grinding being used as a
5 method for the manufacture of the power particles.

1 78. (New) The method of claim 63, further comprising using an additional
2 heat source so as to carry out said forming from the vapor phase cloud onto the metallic substrate
3 surface an insulating layer, within a predetermined temperature range, with a heat input of the
4 heat source and the temperature in the substrate being controlled independently of said process
5 pressure, and said plasma enthalpy.

1 79. (New) The method of claim 78, wherein the thermally insulating layer
2 system comprises, apart from the thermally insulating layer, a base layer between a base body
3 and the thermally insulating layer and a cover layer on the thermally insulating layer, wherein
4 a) the base layer includes a hot gas corrosion protection layer, the layer
5 thickness of which has a value between 10 and 300 µm, and which comprises at least partly of
6 either a metal aluminide, of a MeCrAlY alloy, with Me signifying one of the metals Fe, Co or

7 Ni, or of an oxide ceramic material and has an either dense columnar or uniformly directed
8 structure,

9 b) the cover layer is a smoothing layer, the layer thickness of which has a
10 value between 1 and 50 µm, and which comprises at least partly of the same or a similar material
11 to the thermally insulating layer, and

12 c) the part layers of the layer system are all applied in a single working cycle.

1 80. (New) The method of claim 78, wherein the thermally insulating layer
2 system includes, apart from the thermally insulating layer, a base layer between a base body and
3 the thermally insulating layer and a cover layer on the thermally insulating layer, wherein

4 a) the base layer includes a hot gas corrosion protection layer, the layer
5 thickness of which has a value between 25 and 150 µm, and which comprises at least partly of
6 either a metal aluminide, of a MeCrAlY alloy, with Me signifying one of the metals Fe, Co or
7 Ni, or of an oxide ceramic material and has an either dense columnar or uniformly directed
8 structure,

9 b) the cover layer is a smoothing layer, the layer thickness of which has a
10 value between 10 and 30 µm, and which comprises at least partly of the same or a similar
11 material to the thermally insulating layer, and

12 c) the part layers of the layer system are all applied in a single working cycle.

1 81. (New) The method of claim 63, wherein the substrate comprises a nickel
2 or cobalt based alloy.

1 82. (New) The method of claim 63, further comprising thermally treating the
2 thermally insulating layer system.

1 83. (New) The method of claim 63, wherein the substrate is a turbine blade of
2 a stationary gas turbine or of an aircraft engine.

1 84. (New) The method of claim 63, wherein the substrate is a guide vane or
2 rotor blade or a component acted on by hot gas.

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- 1 85. (New) The method of claim 63, wherein the substrate is a heat shield in
2 an aircraft engine.